# CONTENTS

## ACKNOWLEDGEMENT

## Chapter I  PREFACE

1.1 Introduction ........................................... 1
1.2 Literature Survey ......................................... 2
1.3 Scope of the present work ............................... 7
1.4 Details of the present work ............................ 7

## REFERENCES ................................................. 12

## Chapter II  PREPARATION OF THIN FILM SAMPLES

2.1 Introduction ............................................. 18
2.2 Vacuum evaporation ..................................... 19
2.3 Hot wall deposition technique .......................... 21
2.4 Materials for film deposition .......................... 23
2.5 Substrates and masks ................................... 24
2.6 MSM structures .......................................... 26
2.7 Thickness measurements ................................ 27

## REFERENCES ................................................. 29

## Chapter III STRUCTURE, MICROSTRUCTURE AND COMPOSITION STUDIES

3.1 Introduction ............................................. 31
3.2 X-ray diffraction technique ............................ 32
| 3.3 | Electron beam technique | 39 |
| 3.4 | Energy dispersive analysis | 43 |
| 3.5 | Photon beam technique | 44 |
| 3.6 | Ion beam technique | 48 |
| REFERENCES | | 52 |

**Chapter IV**  
**DIELECTRIC PROPERTIES**

4.1 Introduction .................................. 55
4.2 General theory of dielectrics .................. 56
4.3 Measurements .................................. 61
4.4 Results and discussion ....................... 62
REFERENCES .................................. 76

**Chapter V**  
**ELECTRONIC CONDUCTION**

5.1 Introduction .................................. 79
5.2 A.C. Conduction ................................ 79
5.3 D.C. Conduction ................................ 90
REFERENCES .................................. 104

**Chapter VI**  
**OPTICAL PROPERTIES**

6.1 Introduction .................................. 107
6.2 Theory .................................. 108
6.3 Spectrophotometric method .................. 112
6.4 Results and discussion ....................... 114
REFERENCES .................................. 120